

Electronic Acknowledgement Receipt

EFS ID:	1259398		
Application Number:	10790492		
International Application Number:			
Confirmation Number:	9512		
Title of Invention:	Atomic layer deposition of capacitor dielectric		
First Named Inventor/Applicant Name:	Lingyi A. Zheng		
Correspondence Address:	DINSMORE & SHOHL LLP One Dayton Centre Suite 500 One South Main Street Dayton OH 45402-2023 US 9372230724 -		
Filer:	James E. Beyer/Theresa Oldfield		
Filer Authorized By:	James E. Beyer		
Attorney Docket Number:	MIO 0082 N2/40509.292		
Receipt Date:	18-OCT-2006		
Filing Date:	01-MAR-2004		
Time Stamp:	12:54:54		
Application Type:	Utility		

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part/.zip	Pages (if appl.)
1	Change of Address	ChangeOfAddress.pdf	270519	no	2
Warnings:					
Information:					
Total Files Size (in bytes):					270519
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p>New Applications Under 35 U.S.C. 111 If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p>National Stage of an International Application under 35 U.S.C. 371 If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>					